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PATENT

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In re application of BAILEY III et al.

Attorney Docket No.: LAM1P124D1

Application No.: 09/943,806

Examiner: Unknown

Filed: August 30, 2001

Group: 1763

Title: TEMPERATURE CONTROL SYSTEM
FOR PLASMA PROCESSING APPARATUS

CERTIFICATE OF MAILING

Thereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on January 3, 2002.

Signed

Kristina Gomez

REQUEST FOR CORRECTED FILING RECEIPT

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Sir:

Enclosed is a copy of the Filing Receipt for the above-identified patent application. Please reprint the Filing Receipt as follows and mail the corrected copy to the undersigned.

Change the Inventor Michael G. R. Smith's address from "Alameda" to --Dublin--.

Since this is a Patent Office typographical error, no fee should be due. However, the Commissioner is authorized to charge any fees that may be due to Deposit Account 500388 (Order No. LAM1P124D1).

Respectfully submitted,

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| APPLICATION NUMBER | FILING DATE | GRP ART UNIT | FIL FEE REC'D | ATTY DOCKET NO | DRAWINGS | TOT CLAIMS | IND CLAIMS |
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CONFIRMATION NO. 4355

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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

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Domestic Priority data as claimed by applicant

THIS APPLICATION IS A DIV OF 09/439,675 11/15/1999 PAT 6,302,966
AND CLAIMS BENEFIT OF 60/165,496 11/15/1999

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Foreign Applications

If Required, Foreign Filing License Granted 10/10/2001

Projected Publication Date: 01/17/2002

Non-Publication Request: No

Early Publication Request: No

Title

Temperature control system for plasma processing apparatus

Preliminary Class

